

PATION Docket No. 046124-5060

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)		
Hirofumi MIYAJIMA et al.		)	Confirmation No.: 3310	
Application No.: 09/773,509		)	Group Art Unit: 1722	·
Filed: February 2, 2001	•	)	Examiner: C. H. Jackson	
For: HEAT SINK AND SEMICONDUCTOR LASER APPARATUS AND SEMICONDUCTOR LASER STACK APPARATUS USING THE SAME		) ) )	TECHNOLOGY	REI
Commissioner for Patents U.S. Patent and Trademark Office 2011 South Clark Place Customer Window Crystal Plaza Two, Lobby, Room 1B03	·		LOGY CENTER 2800	RECEIVED
Arlington, VA 22202			č	2

Sir:

## **AMENDMENT**

In response to the Office Action dated June 19, 2003, the period extending through October 19, 2003, by the Petition for Extension of Time for one-month filed concurrently herewith, please amend the above-identified application as follows:

10/16/2003 BABRAHA1 00000133 500310 09773509 01 FC:1251 110.00 DA